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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **NAKATA, Yoshihiro et al.**

Group Art Unit: 1771

Serial No.: **10/807,174**

Examiner: **VO, Hai**

Filed: **March 24, 2004**

P.T.O. Confirmation No.: **4205**

FOR: **SILICON-BASED COMPOSITION, LOW DIELECTRIC CONSTANT FILM,
SEMICONDUCTOR DEVICE, AND METHOD FOR PRODUCING LOW
DIELECTRIC CONSTANT FILM**

REQUEST FOR STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: September 26, 2005

Sir:

The undersigned attorney requests the status of the above-identified application.

The application was filed on **March 24, 2004** in the U.S. Patent and Trademark Office
and to date no Office Action has been received.

In the event any fees are required in connection with this paper, please charge Deposit
Account No. 01-2340.

Respectfully submitted,

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